Pump-probe experiments on Er coupled Si-nanocrystals rib-loaded waveguides

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ABSTRACT

Pump and probe experiments have been performed on Er-doped rib-loaded waveguides containing Si nanoclusters grown by reactive magnetron sputtering. An Er³⁺ absorption cross-section of about 5x10⁻²¹ cm² has been found at 1534 nm by insertion losses measurements. Transmission measurements at 1310 nm under optical pumping (488 nm) shows a decreasing of the signal because of confined carrier absorption of the Si nanoclusters. Amplification experiments at 1535 nm evidence two pump power regimes: losses due to confined carrier absorption in the Si nanoclusters at low pump powers and signal amplification at high pump powers. For strong optical pumping, signal enhancement of about 1.2 dB/cm was observed.

INTRODUCTION

The convergence of photonics and microelectronics within a single chip is still suffering from the lack of a reliable on-chip optical amplifier. A possible candidate is an Er-doped planar glass optical amplifier operating at 1.5 µm that can compensate for coupling and waveguide losses, and enforce split signals in optical busses. Compact optical amplifiers at 1535 nm with gain value of about 2-4 dB/cm have been demonstrated by using optical pumping [1,2]. However, the gain of Er-doped planar glass optical amplifiers is limited by cooperative up-conversion, which results in a non radiative de-excitation of two interacting excited Er³⁺ ions, and excited state absorption, in which a pump photon is absorbed by an excited Er³⁺ ion. Moreover, direct Er³⁺ excitation requires expensive 980 nm or 1480 nm lasers with quite large pump powers (10-100 mW). To overcome these limitations, alternative schemes have been chased. One of these is the use of suitable Er³⁺ sensitizers [3]. Among the various sensitizers, Si nanoclusters (Si-nc) in SiO₂ are very promising because of their broad and continuous absorption band in the visible. Er³⁺ ions are excited through Auger-type interaction with excitons photo-excited within the Si-nc [4]. This indirect Er³⁺ excitation is fast (~ 1µs), very efficient (>70%), with a large excitation cross section (~10⁻¹⁶ cm² at 488 nm) [4] typical of Si-nc absorption cross section. In addition, the presence of Si-nc in the oxide increases the effective refractive index of the material and allows its use as core layer in a planar waveguide. The demonstration of efficient electroluminescent devices [5] suggests that electrical pumping of the amplifier could be feasible, which further increases the interest in the system for on-chip integration.

Encouraging results reported internal gain by LED (light emitting diode) pumping in silica waveguides doped with Si-nc and Er and also reported an unexpectedly high emission cross section for Er³⁺ of σ_em≈2x10⁻¹⁹ cm² at 1535 nm, roughly two orders of magnitude higher than for Er³⁺ in pure silica [6]. Also, a report of an absorption cross section to a value of σ_abs≈8x10⁻²⁰ cm² at 1535 nm appeared [7].
Here we address the problem of light amplification in Er-doped silica rib-loaded waveguides containing Si-nc grown by reactive sputtering. The effective absorption cross section of the Er$^{3+}$ was measured as well as the propagation losses and signal enhancement by optical pumping in the visible.

SAMPLES AND EXPERIMENTAL METHODS

Er$^{3+}$ coupled to Si-nc rich waveguides have been prepared by reactive magnetron co-sputtering of a pure silica target topped with Er$_2$O$_3$ pellets [8,9]. The incorporation of silicon excess in the film was obtained by mixing the plasma with hydrogen, owing to its ability to reduce the oxygen provided by the silica target [10]. More details on the process have been given elsewhere [8,9]. After the deposition of 0.75 µm thick Er/Si-nc rich layer, a SiO$_2$ cladding layer having a thickness of 1 µm has been deposited by sputtering a SiO$_2$ target in pure argon plasma. Then the samples have been annealed during 1 hour at 900°C under pure N$_2$ flux. About 7 at. % of Si and an Er concentration around $N_{Er} \approx 4 \times 10^{20}$ cm$^{-3}$ (corresponding to about 0.5 at. %) have been determined by Secondary Ion Mass Spectroscopy (SIMS) and Rutherford Backscattering Spectroscopy (RBS) experiments. M-lines measurements allowed determining the refractive index $n$ of the film, giving a value of 1.531 at 1553 nm. Standard processing (optical lithography and reactive ion etching) has been used to define rib-loaded waveguides with rib width ranging between 2 to 6 µm and optical confinement factor $\Gamma \approx 0.55$. The wafers were cut to have 3 cm long waveguides that were used for all measurements.

Propagation losses in the waveguides have been obtained by measuring the insertion losses. Light from a tuneable laser (1.5-1.6 µm) or a diode laser (1.31 µm) was coupled into the waveguide through a single-mode polarization-preserving tapered fiber, and detected with a microscope objective (40x) matched to a zoom (2-12x) mounted on a high performance InGaAs camera and, through a prism beam splitter, was sent to a calibrated Ge detector.

Pump and probe measurements were performed in a similar setup where optical pumping was supplied by an Ar laser (488 nm, up to a power of 2.4 W), focussed on the waveguide surface into a stripe 10 µm wide and 0.9 cm long by means of a cylindrical lens. The alignment of the pump with the rib-loaded waveguide was checked by two cameras for side and top observations. Note that only the last 0.9 cm of the 3 cm long rib waveguide was pumped. The probe signal was chopped (10 kHz, 0.2 mW) and detected through a lock-in to clean the ASE (amplified spontaneous emission) from the amplified signal.

RESULTS

Propagation losses have been determined from insertion losses measurements once the coupling losses have been estimated (about 10 dB) both by calculations accounting for geometrical factors, reflection, misalignments, and by comparison with similar waveguides in which propagation losses have been measured independently [11]. Propagation loss coefficients for unpolarized light at different wavelengths are shown for 5 µm wide rib-loaded in the inset of figure 1. No significant differences either in the modal profile or in the insertion losses for the TE and TM modes have been observed. The difference between losses at 1534 and 1600 nm is due to the Er$^{3+}$ absorption and to the reduction of scattering losses with increasing wavelength. By assuming negligible Er$^{3+}$ absorption at 1600 nm, we can subtract the scattering losses as a function of the wavelength and thus estimate the Er$^{3+}$ absorption contribution to the propagation losses. In figure 1 (dotted line) the result of such an estimate is reported, whereas full line is the luminescence spectrum measured in the waveguide.
Figure 1. Emission (full line) and absorption (dotted line) spectra of Er-doped Si nanoclusters waveguide. The emission spectrum is obtained with an excitation wavelength of 365 nm and excitation optical power of 90 mW. The absorption spectrum is obtained by measuring the insertion losses as a function of the wavelength. Room temperature measurements. The inset reports propagation losses coefficients for 5 µm wide rib-loaded waveguide at different wavelengths.

The Er$^{3+}$ absorption coefficient $\alpha_{\text{abs}} = \Gamma \sigma_{\text{abs}} N_{\text{Er}}$ is about 4.8 dB/cm at 1534 nm, which corresponds to a peak $\sigma_{\text{abs}} \approx 5 \pm 2 \times 10^{-21}$ cm$^2$. This value coincides with that of Er$^{3+}$ in pure silica ($4-7 \times 10^{-21}$ cm$^2$) [11] and contrasts to the value $\sigma_{\text{abs}} = 8 \times 10^{-20}$ cm$^2$ measured at 1532 nm in Ref. [7]. Ion implantation, larger Si excess (13 at. %), smaller $\Gamma$ factor and higher annealing temperature were used in Ref. [7]. The higher annealing temperature causes the complete crystallization of the nanoclusters in Ref. [7], whereas here the annealing temperature was chosen such that the energy transfer efficiency of the Si-nc (still amorphous) was maximized [9].

Figure 2. Luminescence intensity at 1535 nm as a function of the photon flux for resonant (488 nm) and non-resonant (476 nm) excitations. Room temperature measurements. Inset: Er lifetimes measurements as a function of the photon flux for excitation wavelength of 476 nm.

One may wonder whether the Si-nc actually acted as Er$^{3+}$ sensitizers in our waveguides as reported in the literature. A detailed study of these samples was reported in Ref. [9] where Er$^{3+}$...
effective excitation cross sections $\sigma_{\text{exc}} \approx 5 \times 10^{-16} \text{ cm}^2$ have been found at 457 nm. Further evidences of the coupling of the Si-nc with the Er$^{3+}$ ions are reported in figure 2. The luminescence intensity at 1535 nm for both resonant (488 nm) and non-resonant (476 nm) excitation as a function of excitation power has been measured. At low photon fluxes ($\phi < 10^{19} \text{ photon/s cm}^2$) no differences are observed, which implies efficient energy transfer from Si-nc to Er ions, as shown in Ref. [9] for smaller photon flux ($10^{16} - 10^{17} \text{ photon/s cm}^2$). At higher fluxes ($\phi > 10^{20} \text{ photon/s cm}^2$) the emission excited by 488 nm pumping becomes larger than the one excited by 476 nm pumping due to saturation of the Si-nc excitation [13]. In this excitation regime, direct excitation of Er$^{3+}$ becomes more efficient than indirect excitation through the Si-nc.

Er lifetimes have been measured and reported in the inset of figure 2: decay times are about 3.9 ms and remain constant with increasing the photon flux, suggesting that both Auger and Er “concentration quenching” mechanisms (such as cooperative Er upconversion and excited state absorption) are ruled out.

Figure 3. Signal enhancement as a function of the pump photon flux density at 488 nm: (a) at 1310 nm. Inset: carrier concentration as a function of the pump power with a square root fit. (b) at 1534 nm (discs). Squares and triangles refer to the contribution to SE due to confined carrier absorption and Er$^{3+}$ amplification, respectively. Inset: a blow-up of the SE for photon flux of $10^{19} - 10^{21} \text{ photons/s cm}^2$.

Pump-probe results are reported in figure 3 for signal wavelengths of 1310 nm (a) and 1534 nm (b) and pumping wavelength of 488 nm. The transmitted signal intensity under optical pumping $I_{\text{p\&p}}$ can be approximated by $I_{\text{p\&p}} \approx I_{\text{probe}} e^{2(\sigma_{\text{em}} \Gamma N_{\text{Er}}) L}$, where $I_{\text{probe}}$ is the transmitted signal intensity in absence of optical pumping, $N_{\text{Er}}$ is the density of excited Er$^{3+}$, and $L$ is the length of the optically pumped rib waveguide; thus the signal enhancement $SE = I_{\text{p\&p}} / I_{\text{probe}}$. SE measurements at 1310 nm allow investigating the performance of the waveguide under optical pumping in a wavelength region where Er$^{3+}$ is not active. Data shown in figure 3a reveal that $I_{\text{p\&p}}$ decreases with increasing the pump fluxes $\Phi$. We attribute this effect to confined carrier absorption of the signal light within the excited Si-nc [14]. Confined carrier absorption has been observed at 1534 nm for Er$^{3+}$ in Si-nc at high pump powers, and has two effects: it reduces the indirect excitation efficiency of the Er$^{3+}$ ions via the Si-nc and it increases the propagation losses
at the signal wavelength [7]. If we consider, according to Ref. [7], that dN_{carr}/dt = R-CN_{carr}^2 with R the generation rate of carriers and C (cm$^{-1}$s$^{-1}$) a proportionality constant, and assuming that the carrier generation rate is proportional to the pump power, the steady state solution gives: N_{carr} is proportional to $P^{0.5}$. From the relation $\alpha \approx \sigma_{carr} N_{carr} \Gamma$ (where $\sigma_{carr}$ is the free carrier absorption cross-section in bulk silicon [15]) we have determined the free carrier concentration ($N_{carr}$) within the Si nanoclusters as a function of the pump power, which shows this dependence (see the inset of figure 3a).

Figure 3b shows SE at 1534 nm as a function of $\Phi$. Two trends are clear. For low $\Phi$ (i.e. $\Phi < 4 \times 10^{20}$ photons/s cm$^2$), a behaviour similar to the one observed at 1310 nm is measured (see the inset), i.e., confined carrier absorption in the Si-nc dominates. Note that the data reported in Ref. [7] refers to this low pumping regime. For higher $\Phi$, the signal is amplified and a maximum SE $\approx 1.06$ for $\Phi \approx 6 \times 10^{21}$ photons/s cm$^2$ is observed. SE has been observed only for signal wavelengths in the 1530-1540 nm range, i.e. the SE overlaps the absorption peak of Er$^{3+}$ shown in figure 1.

The data reported in the inset of figure 3b, where a region of SE$<1$ is observed, shows that the two processes (confined carrier absorption and Er$^{3+}$ related gain) can be considered additive: Er$^{3+}$ are decoupled from the Si-nc at high photon flux. For this reason, we model the contribution of confined carrier absorption and subtract it from the measured SE. Considering that the free carrier absorption cross-section $\sigma_{fc}(1.54 \mu m) \approx 1.6 \cdot \sigma_{fc}(1.3 \mu m)$ [15], we can estimate the contribution of confined carrier absorption to SE at 1.54 $\mu$m, $SE_{cc}(1.54 \mu m) \approx \exp(-\alpha_{cc}(1.54 \mu m) L) \approx \exp(-1.6 \cdot \alpha_{cc}(1.3 \mu m) L) \approx (SE_{1.3 \mu m})^{1.6}$. This estimate is reported in figure 3b as open squares. By division of the contribution of $SE_{cc}$ to the measured SE, one can isolate the Er$^{3+}$ related contribution to SE, which is plotted in figure 3b as triangles. It is worth to note that confined carrier absorption is an effect dependent on the pumping and not on the probe; moreover, it introduces a loss mechanism but also a turning off of the indirect channel of Er$^{3+}$ excitation so that Er$^{3+}$ is mostly excited through direct absorption. Indeed experiments performed by optically pumping the system at 457 nm (non-resonant wavelength for Er$^{3+}$) do not show any SE up to 250 mW ($\Phi = 1.4 \times 10^{20}$ photons/s cm$^2$). No SE$>1$ has been measured by optically pumping at 532 nm up to $\Phi = 2 \times 10^{21}$ photons/s cm$^2$. It is worth to be noted that 532 nm excitation is not resonant with Er levels, thus confirming that Si-nc are not acting as sensitizers because of the presence of confined carrier absorption, which becomes significant for $\Phi > 1 \times 10^{20}$ photons/s cm$^2$.

In addition, an evaluation of $\sigma_{exc}$ from the SE data following the effective 2 level model of Ref. [6] yields $\sigma_{exc} \sim 6 \times 10^{-21}$ cm$^2$ at 488 nm for high photon flux. This value is rather far from the value obtained in Ref. [9] and the commonly accepted one for the Er$^{3+}$/Si-nc coupled system [4].

From the maximum effective SE of 1.28 due to Er$^{3+}$ it is possible to estimate the number of Er ions in the excited state: as $ln(SE) = 2 \Gamma N_{Er} \sigma_{em} L$ and $\sigma_{em} \approx \sigma_{abs}$, we obtain $N_{Er} = 5 \times 10^{19}$ cm$^{-3}$, i.e. about 12.5% of Er$^{3+}$ is in the excited state. In Ref. [6], a larger $g \sim 7$ dB/cm has been reported for a 2.5 $\mu$m thick waveguide with only 1 at. % Si excess and 0.03-0.05 at. % of Er ($N_{Er} \approx 1-2 \times 10^{19}$ cm$^{-3}$). The use of a very low Si excess and of a short annealing time (5' at 1000 °C) reduced the strength of confined carrier absorption, kept effective the indirect excitation of Er$^{3+}$, and could explain the high g. From the data, an enhanced $\sigma_{em} \sim 2 \times 10^{-19}$ cm$^2$ at 1535 nm was deduced, which is surprising [6]. In fact, the Einstein relation relates $\sigma_{em}$ to the inverse of the radiative lifetime $\tau_{rad}$ of Er$^{3+}$: an increase of $\sigma_{em}$ should correspond to a decrease of $\tau_{rad}$. This was not observed and a luminescence decay time of about 8 ms were reported in Ref. [6].
CONCLUSIONS

Insertion losses and pump and probe measurements on Er dope Si nanoclusters rib–loaded waveguides have shown that at high photon fluxes a sizeable signal enhancement was present, together with a simultaneous lack of enhancement in the absorption cross section of Er$^{3+}$ coupled to Si-nc, and a strong negative role of confined carrier absorption in the Si-nc, which turn off their sensitizer action. In order to obtain efficient all-optical amplifiers with the Er$^{3+}$-Si-nc system the right route could be to decrease significantly the Si excess so to exploit the sensitizer effect of Si-nc and avoid confined carrier losses. Unfortunately we were not able to confirm the order of magnitude increase in the Er$^{3+}$ emission cross section when Si-nc are present.

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